Search Notes	Application No.	Applicant(s)
	10/649,192	ISLAM ET AL.
	Examiner	Art Unit	
	John Juba, Jr.	2872	

SEARCHED

Class	Subclass	Date	Examiner
UPDATED FROM PARENT S/N 10/192,248 (10-9-03) AS:			
359	223	3/18/2004	
359	224	3/18/2004	
359	225	3/18/2004	
359	226	3/18/2004	
359	290	3/18/2004	
359	291	3/18/2004	
359	292	3/18/2004	
359	295	3/18/2004	
359	571	3/18/2004	
359	572	3/18/2004	
359	573	3/18/2004	

INTERFERENCE SEARCHED

Class	Subclass	Date	Examiner

SEARCH NOTES
(INCLUDING SEARCH STRATEGY)

	DATE	EXMR
IEEE Xplore™: grating* <sentence> (micromachin* or deformable or MEMS or MOEMS)	3/18/2004	
EAST text search attached.	3/18/2004	

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